

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application		OPGS File No. P/4745-3 10/542276	
		Applicant Kyung-Hwa PARK			
		Filing Date		Group Art Unit	


U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>KN</i>	JP 3,052,774	07-1998	Japan			abstract	
<i>KN</i>	KR 20-263,127	01-2002	Korea			abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
		Korean International Search Report PCT/KR2004/000048 dated 3 June, 2004

Examiner <i>Kendryga</i>	Date Considered <i>08/28/07</i>
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 <p>APPLICANT'S PART CITATION (Use several sheets if necessary)</p>		Application 10/542,276		OFGS File No. P/4745-3			
		Applicant Kyung-Hwa PARK					
		Filing Date July 14, 2005		Group Art Unit			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)							
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>KN</i>	NZ 517258	09-2002	New Zealand			X	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>KN</i>		Examination Report issued by New Zealand Patent Office on October 12, 2005 in					
<i>KN</i>		connection with corresponding patent application no. 541034					
Examiner <i>Kent Gyeon</i>		Date Considered 08/28/07					
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